# Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

### Listing of claims:

Please cancel claims 2-4, 6-11, 13-15, 19, 20, 30, 33, 40 and 41; withdraw claims 16-18, 24-27 and 37-39; and amend claims 1, 5, 12, 21-23, 28, 29, 31, 32, 34-36.

1. (Amended) A method for determining the presence and concentration of gases by means of monitoring the change in photons in a sensing system comprising passing photons though through a waveguide, which is coated with a porous transparent material and impregnated with a sensing media; and further comprising a mean means to couple the optical signal in the waveguide to the sensing material in the coating via evanescent wave absorption, and further comprising a display means, and further comprising at least one sensor which response responds to at least one target gas and can be monitored by an electronic circuit and further comprising a photon emitter and a photon detector, and further comprising coating the waveguide with a porous silica layer between 20 nm and 200 nm and then coating the porous silica surface with a sensing agent.

Claims 2-4 (Cancelled)

5. (Amended) An apparatus that measure measures the identity and concentration of gases and vapors comprising at least one optical evanescent field absorption sensor; and further comprising a photon emitter and a photon detector; and further comprising a waveguide coated with a porous transparent material that is an oxide; and further comprising a ring waveguide coated with a sensing material coated onto the transparent porous oxide, the sensing material changing its optical properties when exposed to a target gas; and further comprising means to couple photons from the straight waveguide section to the ring waveguide and remove a portion of those photons and then detect a target gas by monitoring the amount of photons at the end of the straight waveguide.

Claims 6-11 (Cancelled)

- 12. (Amended) The method as claimed in claim [11] I wherein the step of coating the waveguide is to immerse the waveguide in a chemical reagent comprising at least one of the following groups for several hours:
- Group 1: Palladium salts selected from the group consisting of palladium sulfate, chloride, bromide and mixture thereof;
- Group 2: Heteropolymolybdates such as silicomolybdic acid, ammonium molybdate, alkali metal molybdates;
  - Group 3: Copper salts of sulfate, chloride, bromide and mixtures thereof; [7]
- Group 4: Alpha, beta, gamma, and or delta cyclodextrins and their derivatives and mixtures thereof; [7]
  - Group 5: Soluble salts of alkaline and alkali chlorides and bromides and mixture thereof;
- Group 6: Inorganic or organic acid and or salt of organic or inorganic compound that dissolve in the mixture in the presence of the acid(s); and
- Group 7: Strong oxidizer such as nitric acid, hydrogen peroxide or mixture thereof and further removing the waveguide and porous outer layer from the solution and then dry the waveguide system slowly over [I] 1 to 2 days to form the supramolecular sensing complex.

#### Claims 13-15 (Cancelled)

- 16. (Withdrawn) A method of measuring the concentration of carbon monoxide using a porous transparent monolith that is coated with a chemical sensing agent comprising an optical cavity that surrounds the sensor on at least 2 reflective surface facing each other with the sensor in between them and there is further a photon source that emits photons that are pass through the sensor monolith and are then striker the reflector; and further the photons are reflected of the surface and direct to pass through the sensor again and this process repeat at least one more cycle striking the second reflector and being direct to pass through the transparent sensor place between the reflectors that response with an optical change proportional to the CO exposure ands the speed of detection proportional to the number of times the photon beam passes though the sensor before striking the photon detector.
- 17. (Withdrawn) A method as claimed in claim 16 that comprises a silica porous monolith with average pore diameter of I0 to 30 nm and the sensing agent is applied by immerse the porous transparent silica monolith in a chemical reagent comprising at least one of the following groups for several hours:

- Group 1: Palladium salts selected from the group consisting of palladium sulfate, chloride, bromide and mixture thereof;
- Group 2: Heteropolymolybdates such as silicomolybdic acid, ammonium molybdate, alkali metal molybdates
  - Group 3: Copper salts of sulfate, chloride, bromide and mixtures thereof,
- Group 4; Alpha, beta, gamma, and or delta cyclodextrins and their derivatives and mixtures thereof,
  - Group 5: Soluble salts of alkaline and alkali chlorides and bromides and mixture thereof;
- Group 6: Inorganic or organic acid and or salt of organic or inorganic compound that dissolve in the mixture in the presence of the acid(s); and
- Group 7: Strong oxidizer such as hydrogen peroxide and or nitric acid. and further removing the waveguide and porous outer layer from the solution and then dry the waveguide system slowly over 1 to 2 days to form the supramolecular sensing complex.
- 18. (Withdrawn) A method as claimed in claim 17 where the porous silica is made by a solgei method and the average pore diameter id 16 nm to 27 nm.

### Claims 19-20 (Cancelled)

- 21. (Amended) An apparatus as claimed in claim 5 that measures the identity and concentration of gases and vapors comprising at least one optical evanescent field absorption sensor; and further comprising a photon emitter and a photon detector; and further comprising a waveguide coated with a porous transparent material, the waveguide in the shape of a ring and further comprising a very thin coating on the ring with a sensing material in the coating; and further comprising a straight waveguide in the immediate vicinity and running tangent to the ring waveguide and [a] means to switch the photons from the straight waveguide to the ring waveguide and a means to switch the photon from the ring back to the straight waveguide and [a] means to detect the change in evanescent field absorption due to one or more target gases by monitoring the amount of photons at the end of the straight waveguide.
- 22. (Amended) An apparatus as claimed in of claim 21 comprising more than one light source each with different wavelengths and means to read each wavelength independently.

- 23. (Amended) An apparatus as claimed in of claim 22 further comprising several photon sources of different wavelengths and at least one photon detector and there is a means to measure each wavelength separately by pulsing the photon source at different [time] times and reading the many different wavelengths; and further an analog to digital converter to convert the analog signal to digital and further comprise a comprising means to store the digitized signal from each wavelength and compare the signal patterns [form] from each wavelength to a pattern stored in the microprocessor and an algorithm that will interpret the various signal patterns to identify the gases present and estimate their concentrations.
- 24. (Withdrawn) A multi-pass photon sensing gas detector apparatus for determining the target gas concentration and identity comprises: a microprocessor and a means for assigning sensor reading values to each of the measured optical characteristics; means for determining differences between sensor reading values;

memory for storing the differences; an alarm register for adding the sum of a plurality of the differences stored in the memory; and means for entering an alarm mode when value of the alarm register exceeds an alarm point; and further comprising a sensing system as follows: a porous transparent monolith "that is coated with a chemical sensing agent comprising an optical cavity that surrounds the sensor on at least 2 reflective surface facing each other with the sensor in between them and there is further a photon source that emits photons that are pass through the sensor monolith and are then striker the reflector; and further the photons are reflected of the surface and direct to pass through the sensor again and this process repeat at least one more cycle striking the second reflector and being direct to pass through the transparent sensor place between the reflectors that response with an optical change proportional to the CO exposure ands the speed of detection proportional to the number of times the photon beam passes though the sensor before striking the photon detector.

25. (Withdrawn) A multi-pass photon gas detection apparatus as claimed in 24 comprising a means to optically sense at least two sensors in a differential measuring system comprising:

an optical means to sense the target gas; a control optical means for sensing the environment the same as the target gas sensor but does not respond to the gas;

measuring means for measuring the difference in the characteristics of the sensor; and control;

means for determining magnitude of the measured difference in optical characteristics and the intensity of the difference, including a means to monitor accurately the target gas concentration when first sensor responding to the target gas and control sensor regenerates so fast no optical response is seen.

26. (Withdrawn) A multi-pass photon gas detection apparatus as claimed in claim 25 comprises:

at least one photon source; and at least one photodetector optically coupled with the sensor and the photon source for producing a photocurrent proportional to the measured characteristics of the sensor; and

further comprising a control sensor and a means to measure the difference between any CO sensor and the control a capacitor coupled to the photodetector, the capacitor being charged by the photocurrent; and

a microprocessor coupled to the capacitor for measuring time for charge on the capacitor to reach a threshold, the measured time being proportional to the darkness of the sensor.

27. (Withdrawn) A multi- pass photon gas detection apparatus as claimed in claimed 25 comprising an A to D converted to digitize the signal from the photodetector; and

further comprising a means to incorporate the device into a fuel cell vehicle to control the reformer process by measuring CO in milliseconds; and

further comprises a sensor to selectively detect CO in the presence of hydrogen and CO2; and further comprising a porous transparent monolith that is coated with a chemical sensing agent comprising an optical cavity that surrounds the sensor on at least 2 reflective surface facing each other with the sensor in between them and

there is further a photon source that emits photons that are pass through the sensor monolith and are then striker the reflector; and further the photons are reflected of the surface and direct to pass through the sensor again and this process repeat at least one more cycle striking the second reflector and being direct to pass through the transparent sensor place between the reflectors that response with an optical change proportional to the CO exposure ands the speed of detection proportional to the number of times the photon beam passes though the sensor before striking the photon detector.

28. (Amended) An evanescent photon absorption sensor based gas detector apparatus as in claim 6 apparatus that measures the identity and concentration of gases and vapors

comprising at least 2 sensors and sensor monitoring system and a means to condition the sample and a one optical evanescent field absorption sensor; and further comprising a photon emitter and a photon detector; and further comprising a waveguide coated with a porous transparent material that is an oxide; and further comprising a sensing material coated onto the transparent porous oxide that changes its optical properties when exposed to a target gas, and further comprising comprising at least two sensors and sensor monitoring system and means to condition the sample and means to switch the gas from the reformate stream to a air stream and back periodically; and further comprising a microprocessor to control the switching and to process and digitize the signals from the photodetector(s) to determine the CO gas concentration in a fuel cell reformate stream, and further comprising [a] means to incorporate the device into a fuel cell vehicle to control the reformer process by measuring CO in milliseconds; and further comprises a sensor to selectively detect CO in hydrogen and CO2, [a] means indicate need of service, and a-means to protect the occupants from the gases detected.

29. (Amended) An evanescent photon absorption sensor based gas detector apparatus as claimed in of claim 28 further comprising:

at least two photon sources in each sensing chamber;

at least one photodetector optically coupled to receive photons from the photon sources as modified by the sensor and at least two photon source for emitting photons at different wavelengths that in term measure the response of the sensor(s) to CO and humidity; and a means to determine the CO and humidity component to the signal; and

further comprising a chemical reagent comprising at least one of the following groups for several hours:

- Group 1: Palladium salts selected from the group consisting of palladium sulfate, chloride, bromide and mixture thereof;
- Group 2: Heteropolymolybdates such as silicomolybdic acid, ammonium molybdate, alkali metal molybdates;
  - Group 3: Copper salts of sulfate, chloride, bromide and mixtures thereof; [-,]
- Group 4: Alpha, beta, gamma, and or delta cyclodextrins and their derivatives and mixtures thereof; [7]
- Group 5: Soluble salts of alkaline and alkali chlorides and bromides and mixture thereof; and
- Group 6: Inorganic or organic acid and or salt of organic or inorganic compound that dissolve in the mixture in the presence of the acid(s).

### Claims 30 (Cancelled)

31. (Amended) An evanescent photon absorption sensor based gas detector-apparatus as claimed in claim 6 that measures the identity and concentration of gases and vapors comprising at least one optical evanescent field absorption sensor; and further comprising a photon emitter and a photon detector; and further comprising a waveguide coated with a porous transparent material that is an oxide and further comprising a sensing material coated onto the transparent porous oxide that changes its optical properties when exposed to a target gas, and further comprising two sensors in two separate housing each comprising more than one photon source each of a different wavelength; and further comprising a sample conditioning system that eonsist consists of a thermoelectric cooling section and a heating section, between the cold section and the heating section is a membrane to prevent water from passing and [a] means to periodically remove excess water; and further comprising

the CO detector system with at least two separate chambers with valves connecting the sensors alternately to the air and a reformate gas sample; further comprising a display means to indicate the need to perform maintenance; and further comprising at least two sensor, which one responses responds to the CO in the hydrogen stream while at least one remains outside the stream and is regenerated in clean air, and further comprising [a] means to switch the flows of clear air through one of the sensor chambers and a portion of the hydrogen stream through another sensor chamber and a control means to assure that the concentration of CO directed to the fuel cell is less than a pre- determined concentration; and further comprising and further emprising-at least two optically responding sensors, which response to the CO and humidity; and can be monitored by a low-powered electronic circuit with a current draw of less than 25 microamps; and further emprises comprising a supramolecular complex that is self assembled on to a semi-transparent silica porous substrate; and further comprising a thin semi-transparent sensing layer on the porous transparent substrate comprising palladium, copper and

calcium metals ions, halogen anions and cyclodextrins and there derivatives and an acid.

32. (Amended) A method as of producing a porous transparent layer which provides a sensing platform for a sensing agent in an evanescent field absorption sensor, comprising starting with a silicon alkoxide; and further comprising reacting the silicon alkoxide with an organic material with carbons from 4 to 12; and further comprising hydrolyzing the complex to an Organo-silicon compound that is stable and soluble in elaim 13 a non-polar solvent and further

dissolving the solid Organo-silicon in the solvent to form a solution and then coating a waveguide with the solution and further drying the coating and then heating it to drive off the solvent, and further comprising a process using at least one optically responding sensor(s) monitored by two different photon sources and a -photodetector and the system is calibrated to initiate a signal at a predetermined level of target gas for a predetermined period of time, the method comprising the steps of: intermittently measuring the optical (transmission) characteristics of the sensor(s); and further comprising [a] means to monitor a reformate stream by sampling the stream alternately as a means to alternately direct a sample of gas to the first sensor and air to the second sensor and [the] to reverse the process to allow the first sensor to regenerate and further comprising a sample condition means so that sample of reformate and air enter the sensing chambers at a predetermined relative humidity, pressure and temperature.

# Claims 33 (Cancelled)

34. (Amended) An apparatus a claimed in of claim 28 further comprising a circuit that is use used to calculate the CO concentration and further [a] means to display the digital value of the CO concentration, further comprising a mean means to measure [an] and compensate for temperature value; and further comprising a sensor which consist consists of a porous silica materials coated with a chemical reagent comprising at least one of the following groups:

Group 1: Palladium salts selected from the group consisting of palladium salts of sulfate, palladium sulfite, palladium pyrosulfite, palladium chloride, palladium bromide, palladium iodide, palladium perchlorate, CaPdCI<sub>4</sub>, CaPdBr<sub>4</sub>, Na<sub>2</sub>PdCI<sub>4</sub>, Na<sub>2</sub>PdBr<sub>4</sub>, K<sub>2</sub>PdCI<sub>4</sub>, K<sub>2</sub>PdBr<sub>4</sub>, Na<sub>2</sub>PdBr<sub>4</sub>, CaPdCI<sub>x</sub>Br<sub>y</sub>, K<sub>2</sub>PdBr<sub>x</sub>Cl<sub>y</sub>, Na<sub>2</sub>PdBr<sub>x</sub>Cl<sub>y</sub> (where x can be 1 to 3 if y is 4 or visa versa), and organometallic palladium compounds such as palladium acetamide tetrafluroborate and other similarly weakly bound ligands, and mixtures of any portion or all of the above;

Group 2: Molybdenum, vanadium, and/or tungsten salts or acid salts selected from the group consisting of silicomolybdic acid, phosphomolybdic acids, and their soluble salts, molybdenum trioxide, ammonium molybdate, alkali metal, or alkaline earth metal salts of the molybdate anions, mixed heteropolymolybdates, or heteropolytungstenates and mixtures of any portion or all of the above;

Group 3: Soluble salts of copper halides, sulfates, nitrates, perchlorate, and mixtures thereof, copper organometallic compounds that regenerate the palladium such as copper tetrafluoroacetic acid, copper tritlouroacetylacetonate, and other similar copper compound, and

copper vanadium compounds such as copper vanadate, and soluble vanadium compounds that can be incorporated into the group 2 molybdenum based-keg ions such as phosphomolybdic acid and silicomolybdic acid, and mixtures of any portion or all of the above;

Group 4: Supramolecular complexing molecules selected from the cyclodextrin family including alpha, beta, and gamma as well as their soluble derivatives such as hydroymethyl, hydroxyethyl, and hydoxypropyl beta cyclodextrin, crown ethers and their derivative, and mixtures of any portion or all of the above;

Group 5: Soluble salts of alkaline and alkali halides, and certain transitional metal halides such as manganese, cadmium, cobalt, chromium, nickel, zinc, and other soluble halide such as aluminum; and any mixture thereof;

Group 6: Organic solvent and/or co-solvent and trifluorinated organic anion selected from the group including dimethyl sulfoxide (DMSO), tetrahydrofuran (THF), dimethyl formamide (DMF), trichloroacetic acid, tritluoroacetate, a soluble metal trilluroacetylacetonate selected from cation consisting of copper, calcium, magnesium, sodium, potassium, lithium, or mixture thereof; and

Group 7: Soluble inorganic acids such as hydrochloric acid, sulfuric acid, sulfurous acid, nitric acid, and strong oxidizers such as peroxide, or mixture thereof.

35. (Amended) The An apparatus of claim 28 wherein the microprocessor comprises [a] means for assigning sensor reading values to each of the measured photon characteristics; means for determining differences between sensor reading values;

means for determining differences between sensor reading values;

memory for storing the differences;

an alarm register for adding the sum of a plurality of the differences stored in the memory; and

means for entering an alarm mode when value of the alarm register exceeds an alarm point and: a means to signal when the change has occurred above a pretermined level.

means to signal when the change has occurred above a predetermined level.

36. (Amended) An apparatus as claimed in 29 comprising [a] means to sense at least two sensors in a differential measuring system comprising:

a photon sources and detector means to sense the target gas-; a control means for sensing environment parameters that affect the target gases and compensate for those changes;

control means for sensing environment parameters that affect the target gases and compensate for those changes;

[a] means for measuring the difference in the characteristics of the sensor; and a means for determining magnitude of the measured difference in photon characteristics and the intensity of the difference, including a means to monitor accurately the target gas concentration under a wide range of temperature and humidity.

means for determining magnitude of the measured difference in photon characteristics and the intensity of the difference, including means to monitor accurately the target gas concentration under a wide range of temperature and humidity.

37. (Withdrawn) A gas sensing gas detector apparatus for determining the target gas concentration comprises: a photon source and a sensor that changes its index of refraction when exposed to the target gas; and further comprising

two waveguides one located on opposite sides of the sensor; and further comprising a means to measure the intensity of photon that are switched from waveguide 1 which is illuminated by the photon source to second waveguide proportional to the concentration of target gas; and further comprising a means for entering an signal or control mode when value of photon intensity changes exceeds a predetermined level; and further comprising a sensing system comprising a porous transparent monolith that is coated with a chemical sensing agent comprising an optical element coupling the two waveguides and further

the sensor in between the two waveguides pass photons from first waveguide to the second waveguide in proportion to the amount of target gas exposed to the sensor.

38. (Withdrawn) A gas detection apparatus as claimed in 37 comprising a means to optically sense at least two sensors in a differential measuring system comprising:

an optical means to sense the target gas; a control optical means for sensing the environment the same as the target gas sensor but does not respond to the gas;

measuring means for measuring the difference in the characteristics of the sensor; and control

means for determining magnitude of the measured difference in optical characteristics and the intensity of the difference, including a means to monitor accurately the target gas concentration when first sensor responding to the target gas and control sensor regenerates so fast no optical response is seen.

39. (Withdrawn) A gas detection apparatus as claimed in claim 37 comprises:

at least one photon source; and at least one photodetector optically coupled with the sensor and the photon source for producing a photocurrent proportional to the measured characteristics of the sensor; and further comprising a control sensor and a means to measure the difference between any CO sensor and the control

a capacitor coupled to the photodetector, the capacitor being charged by the photocurrent; and

a microprocessor coupled to the capacitor for measuring time for charge on the capacitor to reach a threshold, the measured time being proportional to the darkness of the sensor.

Claims 40-41 (Cancelled)